

IN THE US PATENT AND TRADEMARK OFFICE

Application Number: Not yet assigned  
Agent's Docket Number ONX-109  
5 Filing Date: Not yet assigned  
Applicant: M. Daneman et al.  
Application Title: Fabrication of and Controlled  
Release of Structures Using Etch-  
Stop Trenches  
10 Examiner: Not Yet Assigned  
Art Unit: Not Yet Assigned

15 I hereby certify that this correspondence is being deposited with the United States  
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20 JENNIFER ADDY PETUKSSON  
Name of Person Signing  
11/13/02  
date

PRELIMINARY AMENDMENT A

25 Commissioner of Patents and Trademarks  
Washington, DC 20231

Sir:

30 Kindly amend the above application as follows:

**SPECIFICATION:**

35 At page 2, line 30, please change "filled" to --lined or  
filled--;  
40 at page 2, line 31, after "etch-stop material" add --to form  
etch-stop trenches--;  
at page 2, line 33, change "filled trenches" to --etch-stop  
trenches--;  
45 at pg. 3, line 28, please add --Figs. **4A-4F** depict cross-  
sectional schematic diagrams illustrating formation of a MEMS  
device according to an alternative embodiment of the present  
invention;--;